	Hits	Search Text	DBs
38	37	((substrate or wafer) same (LCD or panel$3 or unit or clich$2 or area or region or divid$3) same (groove or etch$2 or recess$3 or raise$2) same pattern$4) and (((transfer$3 near4 roll$4) or (print$4 near12 (cylinder or roll$4))) same ((blanket or adhesive or adhesion) near12 (coat$4 or film or layer)) same (resist or photoresist or (cur$4 near12 (resin$4 or material or composition or liquid))))	US-PGPUB; USPAT; FPRS; EPO; JPO; DERWENT; IBM_TDB
39	36	((substrate or wafer) same (LCD or panel$3 or unit or clich$2 or area or region or divid$3) same (groove or etch$2 or recess$3 or raise$2) same pattern$4) and (((transfer$3 near4 roll$4) or (print$4 near12 (cylinder or roll$4))) same ((blanket or adhesive or adhesion) near12 (coat$4 or film or layer)) same (resist or photoresist or (cur$4 near12 (resin$4 or material or composition or liquid))))	US-PGPUB; USPAT

	Hits	Search Text	DBs
40	4	((substrate or wafer) same (intaglio or (print$4 near9 plate) or clich$2) same ((((pluralit$4 or multiple) near29 (area or region or divid$3)) or LCD) same (groove or etch$2 or recess$3 or raise$2) same pattern$4) and ((transfer$3 or roll$3 or collector or print$4) same (blanket or film or layer or adhesion or adhesive) same (print$3 near9 roll$3) same (resist or photoresist or (cur$4 near12 material))) and (((printing adj (roll or cylinder)) near12 blanket) same (pattern or resist or photoresist)) and LG$2Philips.asn.	US-PGPUB; USPAT
41	6	((substrate or wafer) same (intaglio or (print$4 near9 plate) or clich$2) same ((((pluralit$4 or multiple) near29 (area or region or divid$3)) or LCD) same (groove or etch$2 or recess$3 or raise$2) same pattern$4) and ((transfer$3 or roll$3 or collector or print$4) same (blanket or film or layer or adhesion or adhesive) same (print$3 near9 roll$3) same (resist or photoresist or (cur$4 near12 material))) and (((printing adj (roll or cylinder)) near12 blanket) same (pattern or resist or photoresist))	US-PGPUB; USPAT